EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S12	2	"20060097266".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/14 12:08
S15	2	S14 and graphite	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2007/11/14 12:09
S14	11	(US-20030036471-$ or US-20060097266-$).did. or (US-6153165-$ or US-6217842-$ or US-6053973-$ or US-6153166-$).did. or (EP-916750-$ or EP-964084-$).did. or (JP-11171697-$ or EP-916750-$ or EP-916749-$).did.	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2007/11/14 12:09
S17	3	(sic or silicon near2 carbide) near2 (beta or ".beta.") near5 (cvd or chemical near2 vapor near2 deposit$6) same graphite near2 susceptor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/14 12:10
S13	40	(sic or silicon near2 carbide) near2 (beta or ".beta.") and graphite near2 susceptor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/14 12:10
S16	12	(sic or silicon near2 carbide) near2 (beta or ".beta.") near5 (cvd or chemical near2 vapor near2 deposit$6) and graphite near2 susceptor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/14 12:17
S18	25	(sic or silicon near2 carbide) near2 (beta or ".beta.") near5 (cvd or chemical near2 vapor near2 deposit$6) and planar$6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/14 15:41
S19	2773	(".alpha." or alpha or "6h") near10 (sic or silicon near2 carbide) and (beta or ".beta." or "3c") near15 (sic or silicon near2 carbide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:12
S22	4	MATSUMOTO near2 SHOICHIRO.in. and (sic or silicon near2 carbide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:15

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S21	193	MATSUMOTO near2 SHOICHIRO.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:15
S20	13	(".alpha." or alpha or "6h") near10 (sic or silicon near2 carbide) and (beta or ".beta." or "3c") near15 (sic or silicon near2 carbide) near14 (around or circumf$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:17
S23	2537	(".alpha." or alpha or "6h") near10 (sic or silicon near2 carbide) same (beta or ".beta." or "3c") near15 (sic or silicon near2 carbide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:18
S27	23	(sic or silicon near2 carbide) near15 (graphite near5 mask$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:19
S26	2	(".alpha." or alpha or "6h") near10 (sic or silicon near2 carbide) same (beta or ".beta." or "3c") near15 (sic or silicon near2 carbide) and (sic or silicon near2 carbide) near15 (graphite near5 mask$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:19
S25	0	(".alpha." or alpha or "6h") near10 (sic or silicon near2 carbide) same (beta or ".beta." or "3c") near15 (sic or silicon near2 carbide) near16 (graphite near5 mask$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:19
S28	132	(".alpha." or alpha or "6h") near10 (sic or silicon near2 carbide) near2 (wafer or substrate) same (beta or ".beta." or "3c") near15 (sic or silicon near2 carbide) near6 (film or layer)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:28
S24	3	(".alpha." or alpha or "6h") near10 (sic or silicon near2 carbide) same (beta or ".beta." or "3c") near15 (sic or silicon near2 carbide) near15 (increas$5 or enlarg$6) near15 (diameter or size)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:28
S29	2	"20020170491"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 11:31

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S32	49	two near2 substrate near15 susceptor and @py<"2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 23:29
S31	0	two near2 substrate near15 susceptor near15 graphite	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 23:29
S30	76	two near2 substrate near15 susceptor	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 23:29
S34	1	two near2 substrate near15 susceptor and @py<"2002" and (sic or silicon near2 carbide) near15 (cvd or chemical near2 vapor near2 deposit$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 23:30
S33	29	two near2 substrate near15 susceptor and @py<"2002"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/19 23:30
L7	231	(sic or silicon near2 carbide) near15 mask$6 near15 deposit$6 and @py<"2004"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/20 09:39
L6	393	(sic or silicon near2 carbide) near15 mask$6 near15 deposit$6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/20 09:39
L5	28	(sic or silicon near2 carbide) near15 mask$6 near16 graphite	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/20 09:39
L10	4	"6706114".pn.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/20 12:28
S11	36	(shigehiro near2 nishino or kazutoshi near2 murata).in. and (sic or silicon near2 carbide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/20 12:44

L11	36	(shigehiro near2 nishino or kazutoshi near2 murata).in. and (sic or silicon near2 carbide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2007/11/20 12:44